


<p style="text-align: center;">Search Notes</p> 	<p>Application/Control No.</p> <p>10551514</p>	<p>Applicant(s)/Patent Under Reexamination</p> <p>VAN DER WIEL, APPOLONIUS H. JACOBUS</p>
	<p>Examiner</p> <p>Hsien-ming Lee</p>	<p>Art Unit</p> <p>2823</p>

SEARCHED			
Class	Subclass	Date	Examiner
438	25,26,55	4/30/09	HL
73	861.355,861.356,861.357	4/30/09	HL
438	25,26,55	11/19/09	HL
73	861.355,861.356,861.357	11/19/09	HL

SEARCH NOTES		
Search Notes	Date	Examiner
EAST (USPAT, USPG, USOCR, EPO, JPO, IBM, Derwent)	4/30/09	HL
EAST (USPAT, USPG, USOCR, EPO, JPO, IBM, Derwent)	11/19/09	HL
inventor search	11/19/09	HL

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
	see interference search history	11/19/09	HL

	<p>/Hsien-ming Lee/ Primary Examiner.Art Unit 2823</p>
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